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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of )  
Katsunori NISHI et al. )  
Japanese Priority Application No. 2000-080242 ) Attn: Applications  
Japanese Priority Date: March 22, 2000 ) Branch  
For: SEMICONDUCTOR DEVICE AND )  
METHOD OF FABRICATING THE SAME) Date: March 21, 2001

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents  
Washington, D.C. 20231

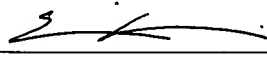
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of these references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Japanese Publication No. 11-501463 corresponds to PCT Publication No. WO 97/24752.

Respectfully submitted,

  
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